

File View Edit Tools Window Help

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- L1: (2762) laser near diode and (photodetector photodiode) and (lead near pin)
- L2: (29) 1 and semiconductor near laser near module
- L3: (774) 1 and semiconductor near laser
- L4: (426) 3 and (stem base submount)
- L5: (1) 3 and (stem near base and submount)
- L6: (57) 3 and (stem near base submount)
- L7: (1) 1 and (stem near base and submount)
- L8: (8) 1 and (stem near base)
- L9: (1280) 1 and (base)
- L10: (384) 9 and semiconductor near laser
- L11: (70) laser near diode and (photodetector photodiode) and (lead near pin)**
- L12: (11) 11 and transmission near line\$1

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US-PGPUB L Plurals

Default operator: OR ☒ Highlight all hit terms initially

laser near diode and (photodetector photodiode) and (lead near pin)

BRS form IS&R form Image Text HTML

	U	I	Document ID	Issue Date	Pages	Title	Current OR	Current XRef
57	<input type="checkbox"/>	<input type="checkbox"/>	US 6186673 B1	20010213	10	Package for optical semiconductor module	385/88	257/684; 257/692
58	<input type="checkbox"/>	<input type="checkbox"/>	US 6181718 B1	20010130	25	Electronically cooled semiconductor laser module with modified ground line	372/34	372/38.08; 372/38.1;
59	<input type="checkbox"/>	<input type="checkbox"/>	US 6163072 A	20001219	17	Semiconductor device package and semiconductor device module	257/704	257/433; 257/99
60	<input type="checkbox"/>	<input type="checkbox"/>	US 6034424 A	20000307	18	Package and optoelectronic device	257/696	257/433; 257/708;
61	<input type="checkbox"/>	<input type="checkbox"/>	US 5940563 A	19990817	18	Receptacle optical module	385/92	
62	<input type="checkbox"/>	<input type="checkbox"/>	US 5907185 A	19990525	13	Ceramic terminal block, hermetic sealed package, and complex semiconductor	257/668	257/674; 257/675;
63	<input type="checkbox"/>	<input type="checkbox"/>	US 5787215 A	19980728	43	Linear PD/LD module, linear PD/LED module, linear LD/PD module, linear	385/88	257/E31.095; 257/E31.108;
64	<input type="checkbox"/>	<input type="checkbox"/>	US 5764826 A	19980609	41	PD/LD module and PD module	385/24	250/227.11; 257/433;
65	<input type="checkbox"/>	<input type="checkbox"/>	US 5675685 A	19971007	35	Optical semiconductor array module, method of fabricating the module, and	385/89	257/98
66	<input type="checkbox"/>	<input type="checkbox"/>	US 5663799 A	19970902	14	Optical diffraction method and apparatus for integrated circuit lead inspection	356/398	250/237G; 356/237.5
67	<input type="checkbox"/>	<input type="checkbox"/>	US 5661835 A	19970826	25	Optical composite module and method of assembling the same	385/92	385/33; 385/47;